

J1011 U.S. PTO
01/08/02
10042666

BEST AVAILABLE COPY

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10042666	FILING DATE 01/08/2002	CLASS 427 418	SUBCLASS 523	GAU 1734	EXAMINER Rodgeff Lavilla
----------------------	---------------------------	---------------------	-----------------	-------------	-----------------------------

**APPLICANTS: Han Nianci; Xu Li; Shih Hong;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 003330 USA/ETCH/METAL/JB
TITLE : Process chamber having component with yttrium-aluminum coating U.S. DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	
ISSUE FEE		Primary Examiner	
Amount Due	Date Paid	Total Claims	Print Claim for O.G.
TERMINAL		DRAWING	
DISCLAIMER		Sheets Drwg.	Figs.Drwg.
PREPARED FOR ISSUE		Print Fig.	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH:

DISK (CRF)

CD-ROM
(Attached in pocket on right inside flap)